



INFORMATION DISCLOSURE STATEMENT	Case Name.	Kornblit 18-14-12-2-5-1-16
	Serial No.	10/649285
	Applicant:	A. Kornblit, et al.
	Filing Date:	August 27, 2003
	Group:	

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date
AV	AA	6,185,961	2/13/2001	Tonucci, et al.	65	60.4	1/27/1999
AV	AB	US Pat. App. 10/798064		Arney, et al			3/11/2004
AV	AC	US Pat. App. 10/806543		Arney, et al			3/23/2004
AV	AD	US Pat. App. 10/816569		Gasparian, et al.			4/1/2004
AV	AE	US Pat. App. 10/674448		Hodes, et al.			9/30/2003
AV	AF	US Pat. App. 10/803565		Hodes, et al.			3/18/2004
AV	AG	US Pat. App. 10/803641		Hodes, et al.			3/18/2004
AV	AH	US Pat. App. 10/403159		Kornblit, et al.			3/31/2003
	AI	US Pat. App. 10/649285		Kornblit, et al.			8/27/2003
AV	AJ	US Pat. App. 10/716084		Kroupenkine, et al.			11/18/2003
AV	AK	US Pat. App. 10/803576		Kroupenkine, et al.			3/18/2004
AV	AL	US Pat. App. 10/810774		Kroupenkine, et al.			3/26/2004

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation

OTHER (including Author, Title, Date, Pertinent Pages, etc.)

AV	AM	Kim, et al., "Nanostructured Surfaces for Dramatic Reduction of Flow Resistance in Droplet-Based Microfluidics," IEEE, pp. 479-482 (2002).

***References listed beyond AZ would list as AA-1, AB-2, AC-3 thru AZ-26.

***Note First Page ONLY Header/Footer. Subsequent pages must ONLY have page # layout as header

EXAMINER Ajay Vamda	DATE CONSIDERED 7/19/04
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609: Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant